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TC 1700

TSMC01-796/786

July 28 2003

1742
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8/26/3
Jules



To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

ATTN: GROUP ART UNIT 2823 M. ESTRADA

FR: Stephen B. Ackerman Reg. No. 37761
28 Davis Avenue
Poughkeepsie
NY 12603
Subject:

Serial No. 10/042,573

01/09/02

"Removal of SiON residue after CMP"

K-H Wei, K-W Chen, S-T Chang, Y-K Lin,
T-C Wang, and Y-L Wang

Grp. Art Unit : 1742

M. Estrada

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AUG 15 2003
TECHNOLOGY CENTER 2800

RESPONSE TO PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated May 2 2003, in the above identified application for patent, please enter the following amendments and consider the following remarks.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents and Trademarks, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 31, 2003.

Name

Signature/Date

STEPHEN B. ACKERMAN REG. NO. 37,761
[Signature] 7/31/03